

IN THE CLAIMS

Please cancel claims 17-19 and add the following new claims.

1 25. (New) The apparatus of claim 24 wherein said metal film includes a noble  
2 metal.

D 1 26. (New) The apparatus of claim 24 wherein said first semiconductor film  
2 has a first oxide film formed thereon.

1 27. (New) The apparatus of claim 24 wherein said metal film is formed on a  
2 second film of oxide formed on said second substrate.

REMARKS

New claims 25-27 are based upon cancelled claims 17-19. Applicant respectfully requests entry of the amendments.

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